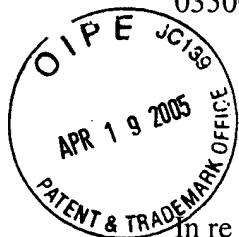


IFW

03500.017972..

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KOICHI MATSUDA ET AL.

Application No.: 10/807,103

Filed: March 24, 2004

For: STACKED PHOTOVOLTAIC
ELEMENT AND METHOD
FOR PRODUCING THE SAME

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Examiner: A.D. Diamond

Art Unit: 1753

April 18, 2005

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449, copies of which are also enclosed.

For the concise explanation of relevance of the non-English document JP2001-308354, the Examiner is respectfully referred to the English abstract attached to the non-English document, and for the relevance of the article, to the specification at page 3.

For the concise explanation of relevance of the JP2-237172, the Examiner is respectfully referred to the English abstract attached there to, and also to counterpart U.S. Patent No. 5,021,100.

An English abstract of non-English document JP 63-77167 is not available.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

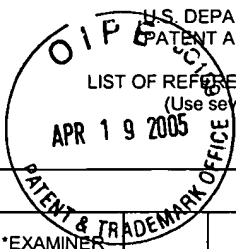
Respectfully submitted,



Leonard P. Diana
Attorney for Applicants
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New York, New York 10112-3801
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FORM PTO 1449 (modified)				ATTY DOCKET NO. 03500.017972		APPLICATION NO. 10/807,103	
<div style="text-align: center;">  </div> LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				APPLICANT KOICHI MATSUDA ET AL.			
				FILING DATE March 24, 2004		GROUP 1753	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,021,100	06/04/91	Ishihara et al.	136	249	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	JP	2001-308354	11/02/01	Japan			Abstract
	JP	2-237172	09/19/90	Japan			Abstract
	JP	63-77167	04/07/88	Japan			No
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
		Yamamoto, Kenji, "Thin-film polycrystalline Silicon Solar Cell", Applied Physics, The Japanese Society of Applied Physics: May 2002, Vol. 71 No. 5, pp. 524-527.					
EXAMINER				DATE CONSIDERED			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1